


APPLICATION DATA SHEET

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Title of Invention	[PHYSICAL VAPOR DEPOSITION PROCESS AND APPARATUS THEREFOR]		
Application Type : regular, utility Attorney Docket Number : 12739-US-PA			
Correspondence address: Customer Number: 31561 			
Priority Data: Doc.No: 93107410; Country -TW ; Date: 2004-03-19 us-priority-claimed			
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